	Y	
Notice of Allowability	Application No.	Applicant(s)
	09/550,640	KUROKAWA ET AL.
	Examiner	Art Unit
	Kelly L. Jerabek	2622
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	ears on the cover sheet with the c (OR REMAINS) CLOSED in this ap or other appropriate communication IGHTS. This application is subject to a and MPEP 1308.	orrespondence address plication. If not included n will be mailed in due course. THIS
1. A This communication is responsive to Amendment filed 9/20	<u>0/2006</u> .	
2. The allowed claim(s) is/are 48 and 55-58.		
 3. Acknowledgment is made of a claim for foreign priority ur a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 		
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority do	cuments have been received in this	national stage application from the
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
5. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.	
(a) I including changes required by the Notice of Draftspers	son's Patent Drawing Review (PTO-	-948) attached
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		
(b) including changes required by the attached Examiner's Paper No./Mail Date		
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t		
 DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT 		
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. ☐ Notice of Informal F	Patent Application
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summary Paper No./Mail Da	(PTO-413),
3. Information Disclosure Statements (PTO/SB/08),	7. Examiner's Amendi	ment/Comment
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛭 Examiner's Stateme	ent of Reasons for Allowance
of Blological Material	9.	
		VIVEK SRIVASTAVA

VIVEK SRIVASTAVA
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2600

Application/Control Number: 09/550,640

Art Unit: 2622

DETAILED ACTION

Allowable Subject Matter

Claims 48 and 55-58 are allowed.

The following is an examiner's statement of reasons for allowance:

Re claims 48 and 55-58, the prior art fails to teach or suggest, "An autofocus apparatus for focusing an image of an object on a surface of an image pickup element for producing an electrical signal utilized as a picture signal, comprising: a photographing optical system including a focus adjusting lens movably provided; a first focusing estimating device to produce focusing information on the basis of a level of a predetermined frequency component included in the electrical signal of the image pickup element; a storage device to store into a memory a correction value when the first focus estimating portion creates the focusing information indicating that the image on the image pickup element is focused on the object; a second focusing estimating device including an imaging lens to image at least a part of light of the object image, split from the photographing optical system, an image re-forming system to re-form images of light beams having passed locations different on pupil position of the imaging lens, a light receiving device to receive the light beams of the images formed by the image re-forming system, a positional deviation detecting device



to detect an imaging positional deviation on the light receiving device, and a correcting device to correct the imaging positional deviation detected by the positional deviation detecting device with the correction value stored in the memory, said second focusing estimating device generating second focusing information to focus the image of the object on said image pickup element with respect to the object; a selecting device to select one of said first focusing estimating device or said second focusing estimating device; and a moving device to move said focus adjusting lens on the basis of the focusing information generated by the selected focusing estimating device by said selecting device".

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Contacts

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kelly L. Jerabek whose telephone number is **(571) 272-7312**. The examiner can normally be reached on Monday - Friday (8:00 AM - 5:00 PM).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Vivek Srivastava can be reached on (571) 272-7304. The fax phone

Application/Control Number: 09/550,640

Art Unit: 2622

Page 4

number for submitting <u>all Official communications</u> is (703) 872-9306. The fax phone number for submitting <u>informal communications</u> such as drafts, proposed amendments, etc., may be faxed directly to the Examiner at (571) 273-7312.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

KLJ Kelly L.J

> VIVEK SRIVASTAVA SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2600